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NOT

OSIO Amendments to the Claims:

5083030005

This listing of claims will replace all prior versions, and listings, of claims in the application:

Listing of Claims:

1-26. (Cancelled)

27. (Currently amended) A method of fabricating a micro-mirror structure in a micro-mirror strip of micro-mirror structures comprising:

forming a pyramidal structure from a first substrate material; and defining electrodes on the pyramidal structure for positioning a mirror disposed adjacent to the pyramidal structure.

- 28. (Original) The method of claim 27, wherein forming the pyramidal structure comprises: anisotropic etching the pyramidal structure to form steps of various depths in the structure.
- 29. (Currently amended) The method of claim 27, wherein the electrodes include four electrodes and forming the electrodes further comprises arranging arranging each electrode on a different one of quadrants of the pyramidal structure.
- 30. (Original) The method of claim 28, wherein the steps are polygonal in shape.
- 31. (Currently amended) The method of claim 27, wherein the substrate material is a first substrate material and wherein a second substrate material is bonded to the first substrate material.